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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE PATENT
APPLICATION OF: Michael Van Der Veen *et al.*
SERIAL No.: 10/790,252
ATTORNEY
DOCKET No: 081468-0308588
FILING DATE: March 2, 2004
ART UNIT : 2829
EXAMINER *not yet assigned*
FOR: LITHOGRAPHIC APPARATUS, METHOD OF SUBSTRATE IDENTIFICATION,
DEVICE MANUFACTURING METHOD, SUBSTRATE, AND COMPUTER
PROGRAM

PRELIMINARY AMENDMENT

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313-1450

Dear Sir:

Prior to initial examination on the merits, please amend the above-identified application as set forth below.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 14 of this paper.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned for under 37 C.F.R. § 1.136(a), and any fees required therefore (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 033975 (Ref. No. 081468-0308588).